

Fig. 1

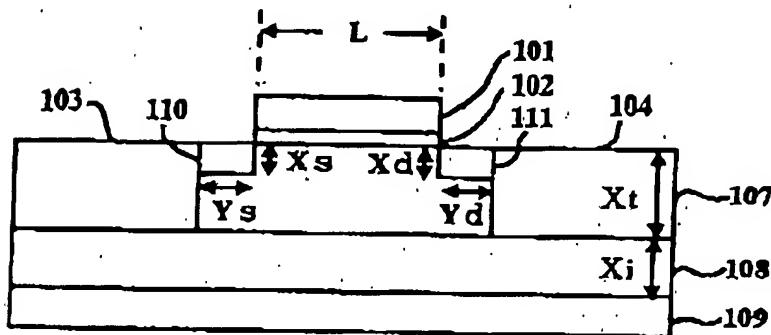


Fig. 2 (a)

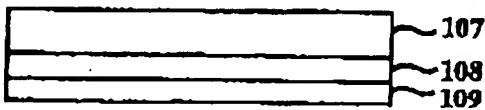


Fig. 2 (b)

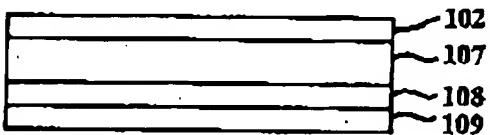


Fig. 2 (c)

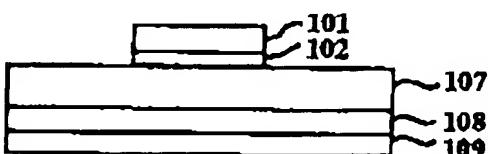


Fig. 2 (d)

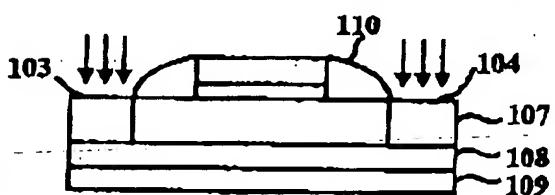


Fig. 2 (e)

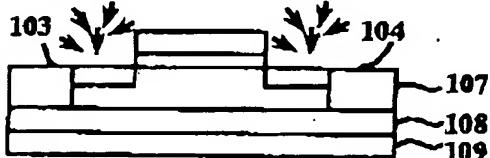


Fig. 2 (f)

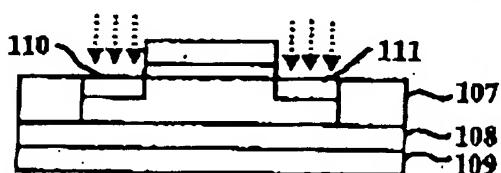


Fig. 3 (a)

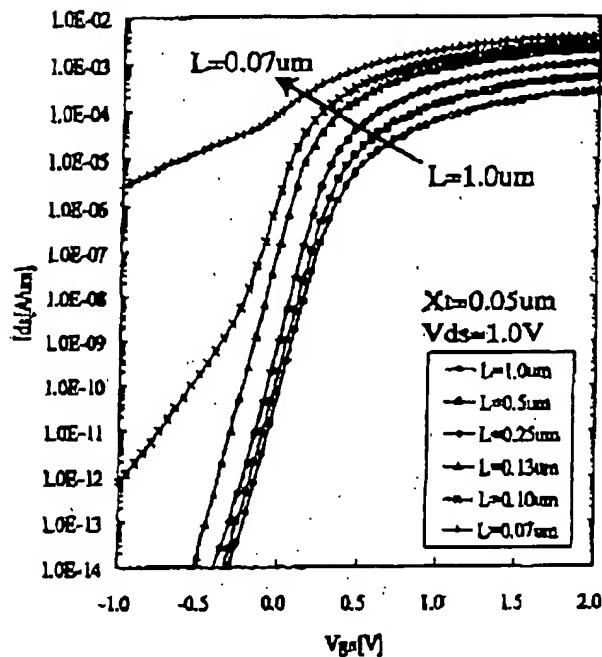


Fig. 3 (b)

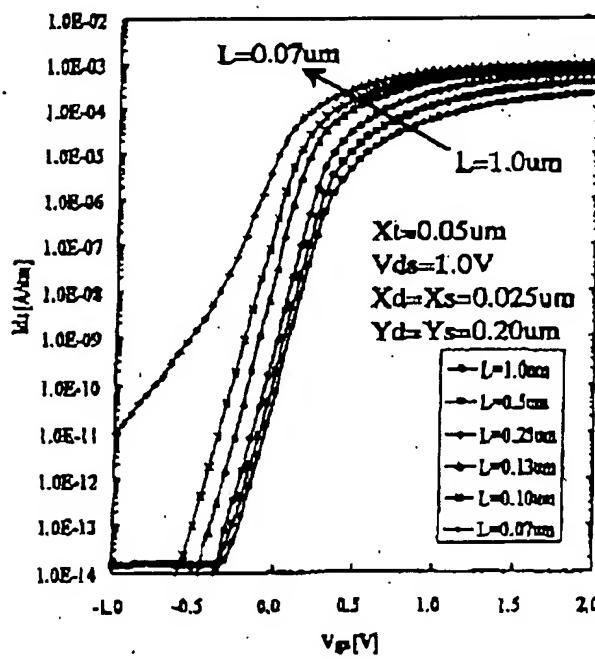


Fig. 4

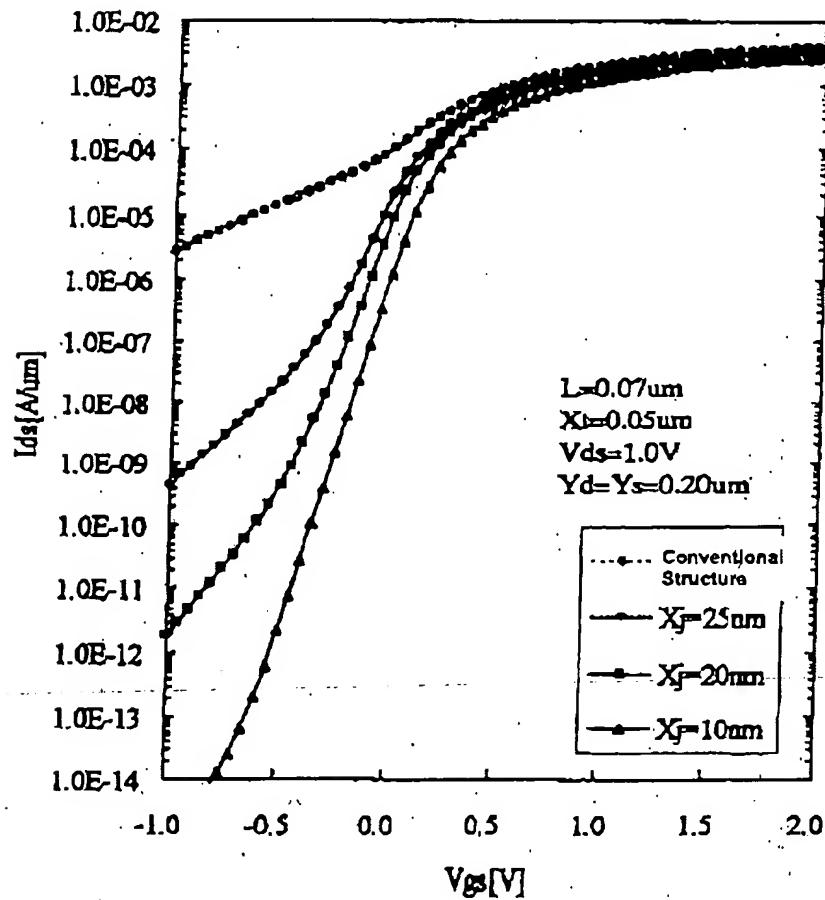
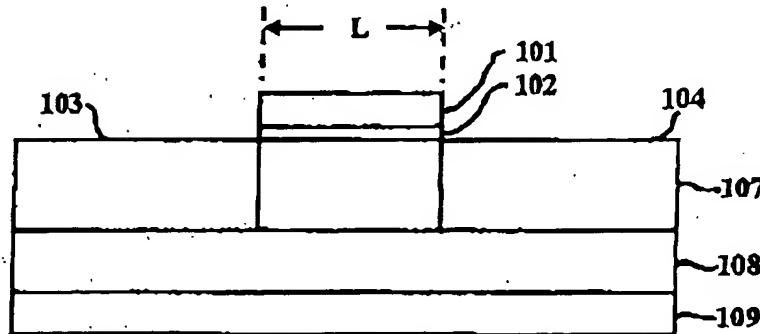


Fig. 5



Title: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE  
Inventor: TAKIZAWA  
Atty. Ref. No.: 9319S-000329

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Fig. 6

